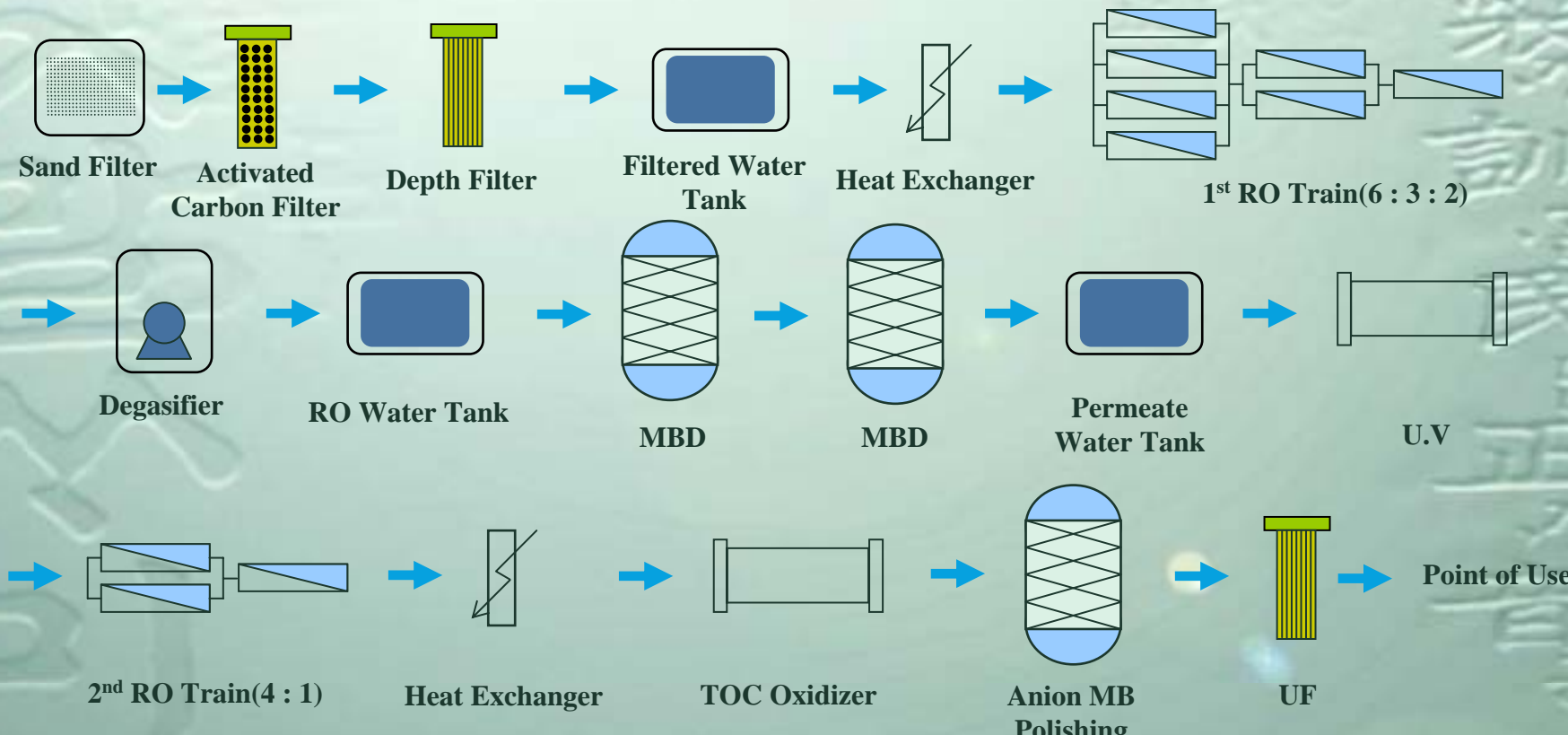


# LG Siltron

- ❖ Ultra Pure Water for Wafer rinsing
- ❖ Bumhan Engineering(韓)

## ❖ Lay out of Equipment



# Details of CSM Installation

## Operating Duration

❖ '99.

## CSM Model

❖ RE8040-BE / 412pcs

## Capacity of Equip.

❖ 5,000m<sup>3</sup>/day  
(calculated by 1<sup>st</sup> RO)

## RO Array

❖ 1<sup>st</sup> RO 6 : 3 : 2 (2set)  
❖ 2<sup>nd</sup> RO 4 : 1 (2set)

## Feed Water

❖ Pretreated Industrial  
Water

## Remarks

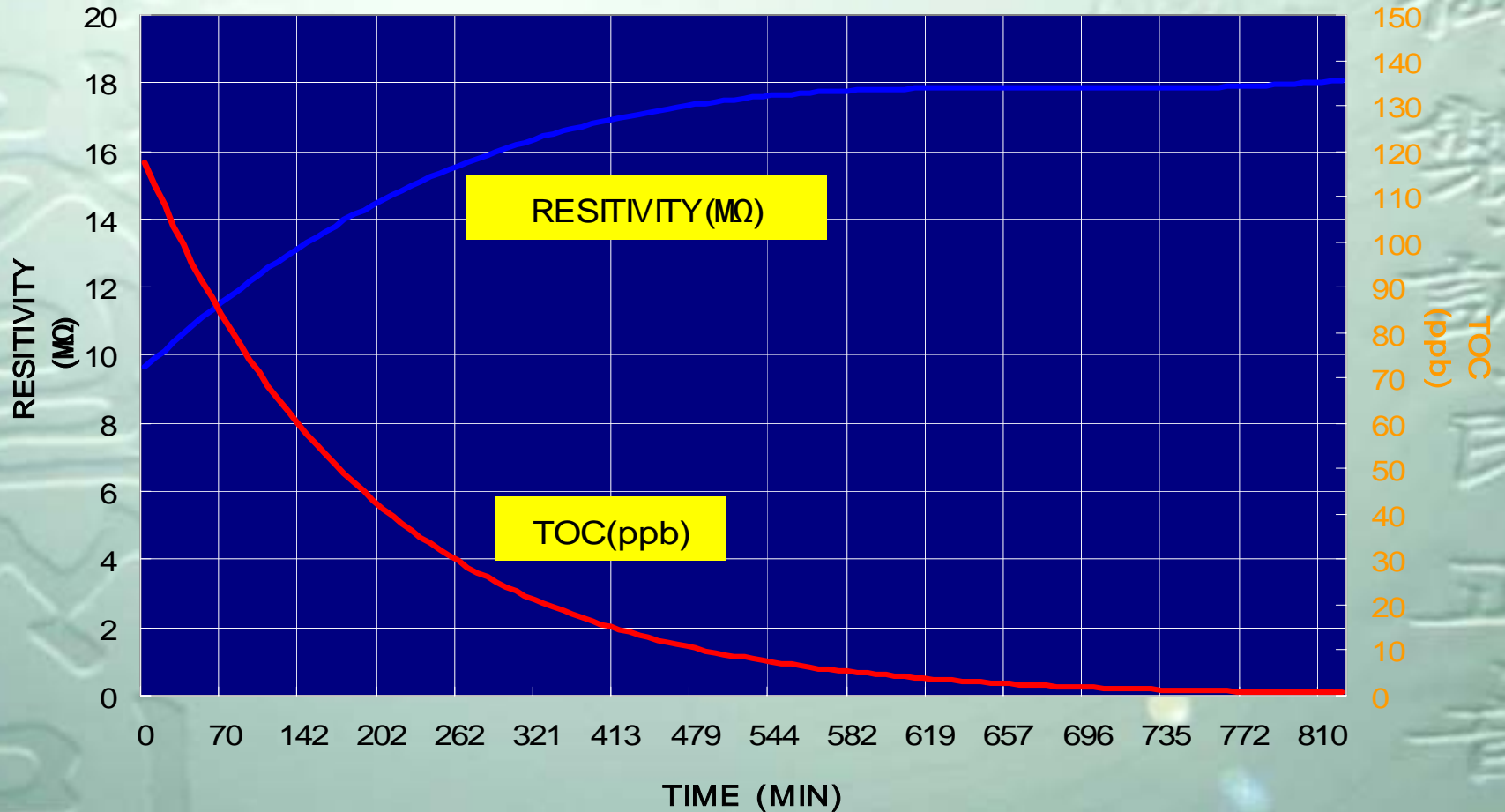
❖ CIP : 1time/3months

## Permeate Quality

❖ Conductivity 18.2M $\Omega$   
❖ TOC 5ppb

# Initial Operating Data

## ❖ Rinse Down Time



# Related Photos

